JSC-09305

NASA TM X-58150 January 1975



A HIGH-INPUT IMPEDANCE DIFFERENTIAL MILLIVOLT METER FOR USE WITH SOLID CERAMIC OXYGEN ELECTROLYTE CELLS

NASA TECHNICAL MEMORANDUM



(NASA-TM-X-58150)	A HIGH-INPUT IMPEDANCE	N75-15939
DIFFERENTIAL MILLIV	OLT METER FOR USE WITH	
SOLID CERAMIC OXYGE	N ELECTROLYTE CELLS	Í
(NASA) 7 p HC \$3.2	5 CSCL 14B	Unclas
<hr/>		<u>G3/35 08919 /</u>

NATIONAL AERONAUTICS AND SPACE ADMINISTRATION

LYNDON B. JOHNSON SPACE CENTER

HOUSTON, TEXAS 77058

			and a bitment of the second
1. Report No. TM X-58150	2. Government Accession No.	3, Recipient's Catalo	g No.
4. Title and Subtitle A HIGH-INPUT IMPEDANCE I	DIFFERENTIAL	5. Report Date January 1971	5
MILLIVOLT METER FOR USE CERAMIC OXYGEN ELECTRO	WITH SOLID LYTE CELLS	6. Performing Organi	zation Code
7. Author(s) Richard J. Williams, JSC, and O. Mullins and E. Quin, Lockheed Electronics Company. Inc.		8. Performing Organiz JSC-09305	zation Report No.
9. Performing Organization Name and Address	······································	10. Work Unit No. 383-35-00-0	0-72
Lyndon B. Johnson Space Cent Houston, Texas 77058	er	11. Contract or Grant	No.
		13. Type of Report a	nd Period Covered
12. Sponsoring Agency Name and Address		Technical M	emorandum
National Aeronautics and Space Washington, D.C. 20546	Administration	14. Sponsoring Agence	y Code
15. Supplementary Notes		<u> </u>	
16. Abstract			· · · · · ·
Design factors are given for a and tested as an inexpensive so motive force from solid ceram	high-input impedance differential llid-state electronic system for us ic oxygen electrolyte cells. A scl	millivolt meter de le in measuring the nematic diagram i	signed, built, e electro- s included.
			İ
	·		
17. Key Words (Suggested by Author(s))	18. Distribution Statem	nent	
Gas Mixtures 'nH	Vieters STAR Subject (latennry: 33 (Floo	tranics and
Measuring Instruments Muf	flers	Electric	al Engr.).
'Electronic Equipment 'Fur	naces		÷., *
· ·	5		`
10 Enquelas Classif (of this separt)			
ra, security classif. (or disteport)	20. Security Classif. (of this page)	21. No. of Pages	22. Price*

*For sale by the National Technical Information Service, Springfield, Virginia 22151

A HIGH-INPUT IMPEDANCE DIFFERENTIAL

MILLIVOLT METER FOR USE WITH SOLID

CERAMIC OXYGEN ELECTROLYTE CELLS

Richard J. Williams Lyndon B. Johnson Space Center Houston, Texas 77058

and

O. Mullins and E. Quin Lockheed Electronics Company, Inc. Houston, Texas 77058

A HIGH-INPUT IMPEDANCE DIFFERENTIAL

MILLIVOLT METER FOR USE WITH SOLID

CERAMIC OXYGEN ELECTROLYTE CELLS

By Richard J. Williams, O. Mullins,* and E. Quin* Lyndon B. Johnson Space Center

SUMMARY

Electromotive force output from solid ceramic oxygen electrolyte cells is usually measured with expensive special electronic devices. An inexpensive solid-state electronic system that accurately measures cell output has been designed, built, and tested at the NASA Lyndon B. Johnson Space Center. The device has functioned successfully for investigators at the Lyndon B. Johnson Space Center.

INTRODUCTION

The solid ceramic oxygen electrolyte cells used for measuring oxygen fugacities in the NASA Lyndon B. Johnson Space Center (JSC) gas-mixing furnaces require a high-input impedance device for accurate measurement of the cells output over their full temperature-response range. The ideal device must respond over the range of 0 to 2000 millivolts and should resolve ±1 millivolt. Usually, special devices (electrometers or pH meters) are used in these measurements; however, these devices are expensive and incorporate features not necessary in the measurement of cell output.

A high-input impedance differential millivolt meter has been designed, built, and tested for use with solid ceramic oxygen electrolyte cells. This device should enable experimenters to reduce costs in building systems similar to that designed at the JSC.

OPERATION AND ADJUSTMENT

The circuit design is rather straightforward (fig. 1). The power supply provides stabilized direct current to the device and also provides controlled direct current to null cell output. Resistor R15 is used to set the span of

*Lockheed Electronics Company, Inc.



Figure 1.- Schematic diagram of a differential millivolt meter.

2

Component	Description
R1, R4, R7	10-k Ω potentiometers
R2, R3, R6	5-k Ω , 1/8 W resistors
R8 R9	1-κΩ, 1/8 W resistor 100-κΩ, 1/8 W resistor Resistor set during calibration
R10	$1-k\Omega$ potentiometer
R11	25-k Ω , 1/8 W resistor
R12	2-k Ω , 1/8 W resistor
R13	71.5-k Ω , 1/8 W resistor
R14	33-k Ω , 1/8 W resistor
R15	100-k Ω potentiometer
C1, C2 C3, C4	100 μ F capacitors 0.001 μ F capacitors PCA IN914 diadors
IC1	Fairchild µA 740 integrated circuit*.
IC2, IC3	Fairchild µA 741 integrated circuits*
IC4	RCA 194 integrated circuit*
Bl	Motorola MDA 970-3 bridge*
т ₁	Stancor P-8394 (for 110-V ac line) transformer* Stancor P-8320 (for 208-V ac line) transformer*
Ml	50-0-50 microammeter

Key

*Or equivalent.

Ę

Figure 1.- Concluded.

3

the power supply output. In the system designed at JSC, the power supply is set for 2000 millivolts full scale. Resistor R10 is a 10-turn potentiometer used to read the nulling voltage. Integrated circuit IC1 is a zero-gain amplifier that serves to isolate the cell from the measurement system. Resistors R1, R4, and R7 are used to balance the amplifiers. The 50-0-50 micrometer is a null indicator; resistor R9 is set by trial and error to adjust the span of the meter to the desired sensitivity. Points 8 and 10 are an output to a recorder; the signal is proportional to the offset from the null position of the device. Transformer T supplies 6 V ac to the power supply from the line voltage.

After the device has been built and prepared for span, sensitivity, and balance, it should be allowed to operate for approximately 24 hours with the input from the cell shunted. Then, a final check of sensitivity and balance should be performed. Finally, a calibrated millivoltage source should be used as an input to adjust the span precisely. Once the device is activated, ideally, it should never be deactivated.

In the operation of a high-input impedance device, standard precautions must be taken: shielded lead wires, clean and dry contacts, physically stable configuration, and good grounds. Because the meter has not been designed to reject alternating-current signals, the sensors must be shielded.

CONCLUDING REMARKS

The high-input impedance differential millivolt meter designed and built at the NASA Lyndon B. Johnson Space Center has proved to be less expensive than other systems for use in measuring the output of solid ceramic oxygen electrolyte cells. Tests indicate the device is highly stable, remains essentially drift free for as long as 2 months, and provides accurate and reproducible measurements.

Lyndon B. Johnson Space Center National Aeronautics and Space Administration Houston, Texas, January 10, 1975 383-35-00-00-72

NASA-JSC